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MAY 27 2005
PATENT & TRADEMARK OFFICE

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of

Woo-Sung JANG

Group Art Unit: 2824

Application No. 10/680,188

Examiner: Luhrs, Michael K.

Filed: October 8, 2003

For: A HIGH DENSITY PLASMA OXIDE FILM DEPOSITION APPARATUS HAVING A GUIDE RING AND A SEMICONDUCTOR DEVICE MANUFACTURING METHOD USING THE SAME

RESPONSE TO ELECTION/RESTRICTION REQUIREMENT

U.S. Patent and Trademark Office
Customer Service Window, Mail Stop Amendment
Randolph Building
401 Dulany Street
Alexandria VA 22314

Sir:

In response to the Office Action of May 10, 2005, Applicants elect the invention of Group I, Claims 1-14, drawn to apparatus. The election is without traverse.

Respectfully submitted,

VOLENTINE FRANCOS & WHITT, PLLC

Adam C. Volentine
Registration No. 33,289

One Freedom Square
11951 Freedom Drive, Suite 1260
Reston VA 21090
Tel. (571) 283-0720
Fax (571) 283-0740

Date: May 27, 2005